

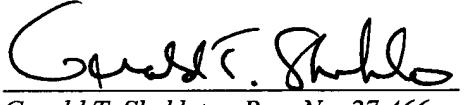


PATENT
Attorney Docket No. 1110/82821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application) Confirmation No.: 6761
)
Applicant: Kozo Nakamura, et al.)
Serial No.: 09/856,212) <i>I hereby certify that this correspondence is being deposited with the United Postal Service as first class mail in an envelope addressed to: Mail Stop AMENDMENT, Commissioner of Patents, P.O. Box 1450, Alexandria, VA, 22313-1450.</i>
Filed: May 18, 2001)
For: PRODUCTION METHOD)
FOR SILICON SINGLE)
CRYSTAL AND)
PRODUCTION DEVICE FOR)
SINGLE CRYSTAL INGOT,)
AND HEAT TREATING)
METHOD FOR SILICON)
SINGLE CRYSTAL WAFER)
)
Examiner: Matthew J. Song)
)
Art Unit: 1722)

June 28, 2006


Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop AMENDMENT
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of March 3, 2006 has been carefully reviewed and the following amendments and remarks are made in response thereto.